L Number	Hits	Search Text	DB	Time stamp
49	12	(micro near hinge) same (micro near machin\$3 or "MEMS")	USPAT;	2004/01/22 17:28
49	'-	(militario media militario)	US-PGPUB;	
	ŀ		EPO; JPO;	
			DERWENT;	
	1		IBM_TDB	
50	27	silicon same (hinge same (three near dimensional) or ("3 near	USPAT;	2004/01/22 18:20
		D"))	US-PGPUB;	
		- 11	EPO; JPO;	
		· · · · · · · · · · · · · · · · · · ·	DERWENT;	
	1		IBM_TDB	
51	24	lin-chuang-chia.in.	USPAT;	2004/01/22 18:21
	1	•	US-PGRUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	0004/04/00 10:01
52	12	lin-chuang-chia.in. and hinge	USPAT;	2004/01/22 18:21
		·	US-PGPUB;	
		·	EPO; JPO;	
			DERWENT;	
			IBM_TDB	2002/00/07 12:46
-	0	((open\$3 or groove or hole) same silicon) same (hinge same	USPAT;	2003/09/07 12:46
		(three near dimensional))	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	2004/04/22 10:10
- 1	1	((single near crystal) near3 silicon) same (hinge same (three	USPAT;	2004/01/22 18:10
		near dimensional))	US-PGPUB;	1 4000 10 6000
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	2002/00/07 12:49
- 	6809	((single near crystal) near3 silicon) same etch\$3	USPAT;	2003/09/07 12:48
	<i>.</i>		US-PGPUB;	11.81 1.51
			EPO; JPO;	
			DERWENT;	
		(micro	IBM_TDB	2003/09/07 12:49
- Ge	182	(((single near crystal) near3 silicon) same etch\$3) same (micro	USPAT;	2003/09/07 12:43
		near machin\$3 or "MEMS")	US-PGPUB; EPO; JPO;	
			DERWENT;	
			IBM_TDB	
		1	USPAT;	2004/01/22 17:20
-	61	((((single near crystal) near3 silicon) same etch\$3) same	US-PGPUB;	200-101722 11 20
		(micro near machin\$3 or "MEMS")) and @pd<20020107	EPO; JPO;	
` '			DERWENT;	
			IBM_TDB	
	_	www.t.l\2 silicon\ nomo otoh\$3\ same	USPAT;	2003/09/07 13:07
-	0	((((((single near crystal) near3 silicon) same etch\$3) same	US-PGPUB;	
1		(micro near machin\$3 or "MEMS")) and @pd<20020107) and	EPO; JPO;	
		(polysilicon near5 cap\$3)	DERWENT;	
			IBM_TDB	
	_	www.t.lb.non2.nilionn).como.otch\$3).came	USPAT;	2003/09/07 13:07
-	0	(((((single near crystal) near3 silicon) same etch\$3) same (micro near machin\$3 or "MEMS")) and @pd<20020107) and	US-PGPUB;	
		(micro near machinas or "NiElvis )) and @pd-20020107) and	EPO; JPO;	
,		(polysilicon same cap\$3)	DERWENT;	
			IBM TDB	
		(Williams and all magra cilicon) came etch\$3) same	USPAT;	2003/09/07 13:08
-	24	((((((single near crystal) near3 silicon) same etch\$3) same (micro near machin\$3 or "MEMS")) and @pd<20020107) and	US-PGPUB;	
		(micro near machinas of ivicivis )) and wpd~20020107) and	EPO; JPO;	9 1 4 1 4 1
		(polysilicon same etch\$3)	DERWENT;	
			IBM_TDB	
	_	(	USPAT;	2003/09/11 17:3
]-	7	(micro near hinge).clm.	US-PGPUB	
1			USPAT;	2003/09/11 17:3
-	157531	sensor.clm.	US-PGPUB	
		1	100-10100	i e
	108	("MEMS" same sensor).clm.	USPAT;	2003/09/11 17:38